



# PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of  
KOROLIK et al. .

Application No.: 10/817,398

**Filed: April 1, 2004**

# For: CONTROLS OF AMBIENT ENVIRONMENT DURING WAFER DRYING USING PROXIMITY HEAD

Group Art Unit: 1746

**Examiner: Heckert, Jason Mark**

Docket No.: LAM2P467

Date: December 12, 2007

**CERTIFICATE OF MAILING**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 12, 2007.

**Signed:**

**Al Pomila**

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 12, 2007, the term to respond extends to December 12, 2007. Please enter this amendment and remarks.

**Amendments to the claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

OK to enter  
SMT